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Official Communication

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Selzer Application No.: 09/332,206

Filing Date: June 12, 1999
Title: Method of Improving X-Ray

Lithography in the Sub 100nm Range to Create High Quality Semiconductor Devices Docket No. 1520-006 (1426)

Date: June 7, 2001 Group Art Unit: 2876 Examiner: I. Kiknadze FAX: 703 305-3594 No. of pages sent: 7

Amendment Under 37 CFR 1.111 Preliminary Amendment

Assistant Commissioner of Patents Washington, D.C. 20231

Sir:

This is a preliminary amendment for a divisional application of this case. Please amend this application as follows. A credit card payment form for the application fee is attached.

CERTIFICATE OF MAILING

I hereby certify that, on the date shown below, this correspondence is being:

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deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

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Date: 6701

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Janes H. Leas

Signature